

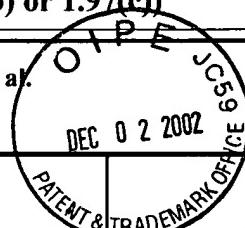
*Supplemental*

*Gp/2811*

**TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT  
(Under 37 CFR 1.97(b) or 1.97(c))**

Docket No.  
GS 174

In Re Application Of: **Richard A. Blanchard et al.**



Serial No.  
**10/039,284**

Filing Date  
**12/31/01**

Examiner  
**Unassigned**

Group Art Unit  
**2811**

**Title: HIGH VOLTAGE POWER MOSFET HAVING A VOLTAGE SUSTAINING REGION  
THAT INCLUDES DOPED COLUMNS FORMED BY TRENCH ETCHING USING AN  
ETCHANT GAS THAT IS ALSO A DOPING SOURCE**

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Address to:

Assistant Commissioner for Patents  
Washington, D.C. 20231

**37 CFR 1.97(b)**

1.  The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.

**37 CFR 1.97(c)**

2.  The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:

the statement specified in 37 CFR 1.97(e);

**OR**

the fee set forth in 37 CFR 1.17(p).

*Supplemental*

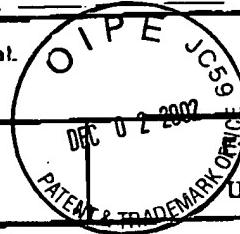
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**Payment of Fee**

(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

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- The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. \_\_\_\_\_ as described below. A duplicate copy of this sheet is enclosed.
  - Charge the amount of \_\_\_\_\_
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Marjorie Searlato

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*Karin L. Williams*  
 Signature

Dated: 11/27/02

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**EXAMINER**

**DATE CONSIDERED**

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